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Docket No.: 740819-466

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Patent Application of)
Takumi MIKAWA et al.)
Serial No. 09/734,176) Examiner: Steven Ho Yin Loke
Filed: December 12, 2000) Art Unit: 2811
For: SEMICONDUCTOR DEVICE AND METHOD)
FOR FABRICATING THE SAME)

#7
Election
FJONES
6-14-02

RESPONSE TO RESTRICTION ELECTION REQUIREMENT

Honorable Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

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In response to the Office Action mailed April 26, 2002, Applicant hereby elects Group I, drawn to a semiconductor device on which claims 1-2 are readable thereon.

In view of the foregoing election, examination on the merits is earnestly solicited and indication of allowance of at least the elected Group is earnestly solicited.

Should the Examiner believe a conference would be of benefit in expediting the prosecution of the instant application, he is hereby invited to telephone counsel to arrange such a conference.

Respectfully submitted,

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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on 5-21-02